

Confirmation No. 3317

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-------------|--|-----------------|-----------------|
| Applicant: | Detecheverry, Celine | Examiner: | Baisa, Joselito |
| Serial No.: | 10/564,582 | Group Art Unit: | 2832 |
| Filed: | January 12, 2006 | Docket No.: | NL030878US |
| Title: | INDUCTIVE AND CAPACITIVE ELEMENTS FOR SEMICONDUCTOR TECHNOLOGIES WITH MINIMUM PATTERN DENSITY REQUIREMENTS | | |

NOTICE OF APPEAL UNDER 37 C.F.R. § 41.31

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Dear Sir:

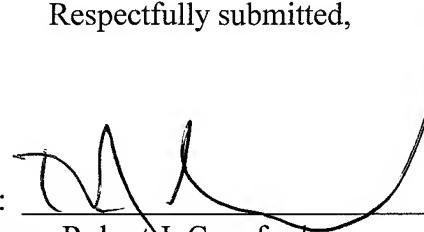
This is a Notice of Appeal for the above-referenced application.

Please charge Deposit Account No. 50-0996 (NXPS.267PA) in the amount of \$510.00 for the large-entity fee required by Rule 41.20(b)(1) and pursuant to the Consolidated Appropriations Act, 2005, signed on December 8, 2004. Also, please charge/credit the same account for any additional fees/overages.

Presented for appeal are claims 1-22.

The undersigned is of record and with authority to prosecute the appeal on behalf of the Assignee.

Respectfully submitted,

By: 
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